



Title: METHOD OF MANUFACTURING NANO-GAP ELECTRODE

Inventor(s): Takashi NAGASE et. al.

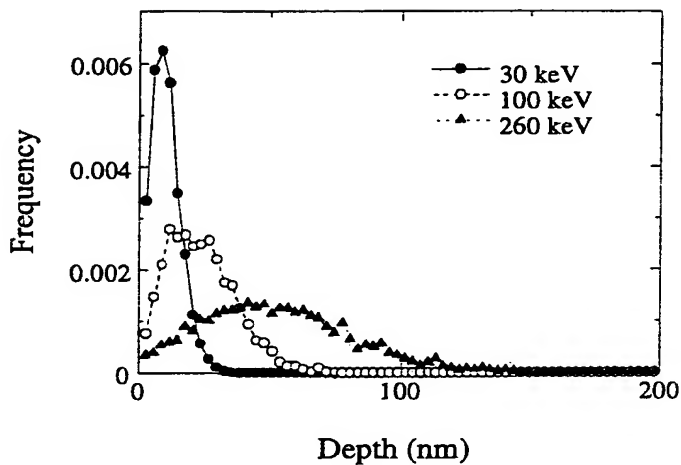
Appl. No.: 10/662,886

REPLACEMENT SHEET

1 / 5

Atty. Dkt. No. 023312-0109

Fig. 1



PRIOR ART